

Notice of References Cited	Application/Control No. 10/602,848	Applicant(s)/Patent Under Reexamination TANAKA ET AL.	
	Examiner Wen-Ying P. Chen	Art Unit 2871	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,678,017	01-2004	Shimomaki et al.	349/40
*	B	US-6,087,678	07-2000	Kim, Dong-gyu	257/59
	C	US-			
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	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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